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(11)

EP 1 234 982 A1

(12)

EUROPEAN PATENT APPLICATION

(43) Date of publication:
28.08.2002 Bulletin 2002/35

(51) Int Cl.7: **F04D 19/04, F04D 25/16,
F04F 5/20**

(21) Application number: **01830121.8**

(22) Date of filing: **22.02.2001**

(84) Designated Contracting States:
**AT BE CH CY DE DK ES FI FR GB GR IE IT LI LU
MC NL PT SE TR**
Designated Extension States:
AL LT LV MK RO SI

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(54) **Vacuum pump**

(57) A turbomolecular vacuum pump (5) comprises a first pumping section (1) having pumping stages with bladed rotor discs, a second pumping section (2) having

pumping stages with smooth rotor discs, a third pumping section (3) having a pumping stage with a toothed rotor disc (26), and a fourth pumping section (4) of the ejector or venturi pump type.

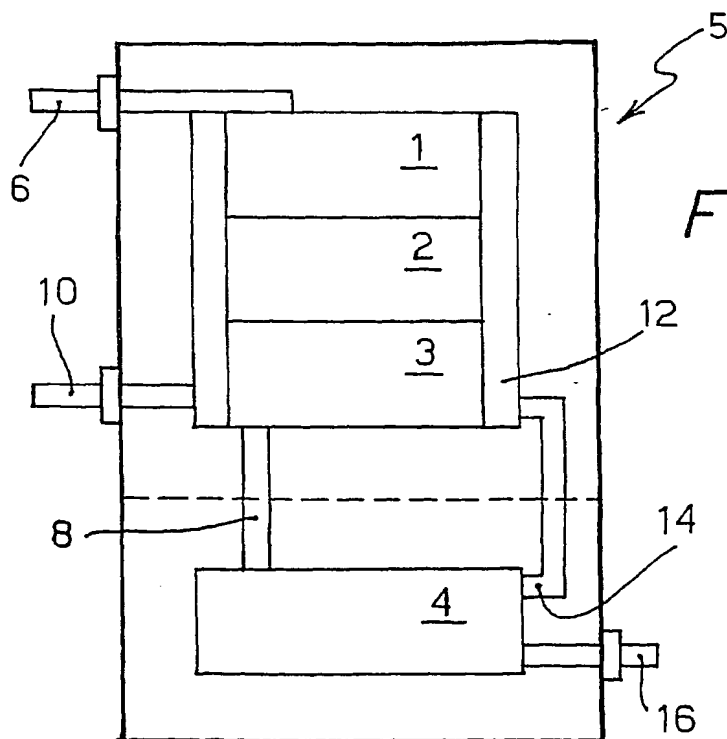


FIG. 1a

Description

[0001] The present invention relates to an improved vacuum pump.

[0002] More particularly, the invention relates to a turbomolecular vacuum pump with a particularly high compression ratio, capable of exhausting at atmospheric pressure.

[0003] Turbomolecular pumps are known which comprise pumping stages with plane or bladed rotors, see for instance EP-B 445 855 in the name of the same Applicant.

[0004] Conventional turbomolecular pumps have rather limited operation ranges, that is, they cannot reach a pressure difference, between the inlet and outlet ducts, such as to allow exhaust at atmospheric pressure. Even if considerable advances have been made in recent years, resulting in the development of turbomolecular pumps allowing exhaust at higher and higher pressures, providing a so-called fore pump coupled with the turbomolecular pump is at present still necessary.

[0005] Fore pumps are coupled outside the turbomolecular pump and therefore they require connection thereto through gas flow ducts, and electrical supply by the same control unit as that supplying the turbomolecular pump. All this makes the pumping system complex and more subject to failures.

[0006] A vacuum generating system, comprising a molecular pump coupled with a fore pump, is disclosed in EP-A 256 234. According to that document, the exhaust port of a molecular rotary pump, comprising a plurality of pumping stages defined by the coupling of a rotor and a stator, is directly connected with a suction duct of a screw pump. The discharge port of the screw pump exhausts at atmospheric pressure.

[0007] The structural complexity of such a system is immediately apparent. Actually the system needs two separate electric motors, since the pumps are to rotate at very different speeds. Moreover, even if the fore pump is equipped with a seal assembly arranged to prevent lubricant from entering the pumping chamber, and hence the molecular pump, pollution is always possible, for instance in case of failures or poor maintenance.

[0008] Ejector or venturi pumps are also known which are actuated by a first, high-pressure fluid and suck a second, low-pressure fluid thereby generating an intermediate pressure level at the outlet. Both the first and the second fluid can indiscriminately be either a liquid or a gas: for instance, by feeding the pump with pressurised water, it is possible to suck a gas such as air, thereby generating a low pressure in a closed space and creating a fore vacuum condition.

[0009] Ejector or venturi pumps, of a kind suitable for sucking a gas, generally can work starting from pressures of about 30 millibars.

[0010] It is an object of the invention to provide a turbomolecular pump capable of exhausting at atmospheric pressure.

[0011] This object is achieved through a turbomolecular vacuum pump comprising, starting from the inlet port, a first pumping section having pumping stages with bladed rotor discs, a second pumping section having pumping stages with smooth rotor discs, a third pumping section having at least one pumping stage with toothed rotor disc, and a fourth ejector or venturi pumping section.

[0012] Advantageously, according to the invention, optimised progressive pumping stages are provided in the turbomolecular pump, capable of bringing the exhaust pressure of the turbomolecular pump to a level suitable for the operation of an ejector or venturi pump, typically 30 mbar.

[0013] According to the invention, the turbomolecular pump is capable of exhausting at a pressure of about 100 mbar already at the third stage.

[0014] Surprisingly moreover, by using a vacuum pump made in accordance with the invention, in particular with a third pumping stage having a rotor disc with straight teeth, an energy saving can be achieved. Indeed, at the exhaust pressure of 30 mbars it has been experienced that the pump having a pumping stage with toothed rotor has lower electric current absorption than a pump not equipped with a stage with toothed rotor disc.

[0015] The above and other objects are achieved by the vacuum pump made in accordance with the invention, as claimed in the appended claims.

[0016] Advantageously, the vacuum pump according to the invention can be used in all applications where a high vacuum condition is required in particularly clean environments, such as for instance in semiconductor working processes.

[0017] The above and other objects of the invention will become more apparent from the description of a preferred embodiment, with reference to the accompanying drawings, in which:

- Fig. 1a is a schematical view of a turbomolecular vacuum pump made in accordance with a first embodiment of the present invention;
- Fig. 1b is a schematical view of a turbomolecular vacuum pump made in accordance with a second embodiment of the present invention;
- Fig. 2 is a cross sectional view of a pumping rotor of a turbomolecular vacuum pump made in accordance with the present invention;
- Fig. 3 is a plan view of a particular pumping stage of a turbomolecular vacuum pump made in accordance with the present invention; and
- Fig. 4 is a side view of an ejector or venturi pumping section of a vacuum pump made in accordance with the present invention.

[0018] Referring to Fig. 1a, a vacuum pump 5, according to a first exemplary embodiment, comprises four different pumping sections 1, 2, 3 and 4, arranged between

a suction duct 6 and an exhaust duct 16. The first three sections are part of a turbomolecular pump, comprising a rotor 20, shown in detail in Fig. 2, and equipped with a plurality of pumping stages defined by rotor discs 22a - 22h, 24a - 24f and 26, coupled with stator rings, not shown in Fig. 2.

[0019] Fig. 2 shows, in cross sectional view, the structure of rotor 20 of the turbomolecular pumping section. The first pumping group 1, including eight rotor discs 22a - 22h with inclined blades, is provided on the pump side proximal to suction duct 6. The blade inclination progressively increases from the first rotor disc 22a to the last rotor disc 22h. Indeed, the blades of the first rotor disc 22a are inclined of about 45° relative to the rotational axis of the rotor, whereas the blades of the last rotor disc 22h are almost horizontal.

[0020] A second pumping group 2, axially aligned with the first pumping group and comprising six smooth rotor discs 24a - 24f, is located below the first pumping stage. The first two smooth rotor discs 24a and 24b have the same diameter as the preceding bladed rotor discs, whereas the last four smooth rotor discs 24c - 24f have smaller diameter.

[0021] A third pumping group 3 comprises a rotor disc 26 with straight teeth and is coupled with a stator ring 30. Rotor 20 further comprises a rotation shaft 28, integral with the rotor discs and driven by a suitable electric motor.

[0022] The third pumping group 3 is shown in detail in Fig. 3. Rotor disc 26, equipped with a plurality of straight teeth 34, is spaced from stator ring 30 so as to form, between the side surface of rotor disc 26 and the inner circumferential surface of stator ring 30, a free and tapered annular channel 36.

[0023] Tapered channel 36 has a suction port and a discharge port located at opposite ends of channel 36 and defining a gas suction region 32 and a gas discharge region 38, respectively. A tapered groove in stator ring 30 forms channel 36 linearly tapered from suction region 32 towards discharge region 38. The transverse size of channel 36 progressively decreases from the suction port towards the discharge port, in counter-clockwise direction, in circumferential direction about rotor disc 26.

[0024] Thanks to rotor 26 with straight teeth and to tapered channel 36, already the third pumping section is capable of exhausting at a pressure of about 100 mbar. However even if such pressure is very high, it does not yet allow a direct connection with the outside environment (i.e. the environment at atmospheric pressure).

[0025] Discharge region 38 of the third pumping section is thus connected, through an intermediate duct 8, visible in the diagrammatic overall view of vacuum pump 5 shown in Fig. 1a, to a fourth ejector or venturi pumping section 4. The fourth pumping section is fed, through a duct 14, by cooling water circuit 12 of the preceding turbomolecular pumping sections. Indeed, the pressurised

cooling water enters pump 5 through an inlet duct 10, passes into cooling circuit 12 of turbomolecular sections 1, 2 and 3, and enters, via duct 14, the fourth ejector pumping section, shown in detail in Fig. 4.

[0026] In the alternative, the fourth pumping section could be fed through a suitable hydraulic circuit, as in the exemplary embodiment shown in Fig. 1b in which the cooling circuit of stages 1, 2 and 3 of the turbomolecular pump is not provided, or when the cooling circuit pressure is not sufficient to actuate ejector pump 4.

[0027] Fig. 1b actually shows a vacuum pump in which the ejector or venturi pumping section 4 is fed by an independent external hydraulic circuit.

[0028] Ejector pumping section 4, shown in detail in Fig. 4, comprises an inlet 14 for pressurised water, a suction duct 8 connected to the outlet of the third pumping section 3, and an exhaust duct 16 from which driving water and sucked gases are exhausted in admixture, at atmospheric pressure.

[0029] Water passage in the ejector or venturi pump actually creates a vacuum in suction duct 8 allowing the pump to exhaust at atmospheric pressure.

[0030] The fourth pumping section 4, having neither moving parts nor electrically powered parts, has a number of advantages. It is not easily subject to failures, it does not require special maintenance and lubrication and does not consume electric power, exploiting the pressurised water coming from the cooling circuit of the turbomolecular sections. Moreover, thanks to its structural simplicity, it scarcely adds to the overall cost of the vacuum pump.

[0031] The absence of lubricated parts in that latter section 4 moreover reduces the possibility of polluting the environment where vacuum is generated.

[0032] The operation principle and the internal structure of an ejector or venturi pump, having inlet and outlet ducts with convergent and divergent cross sections, respectively, are known to those of average skill in the art. Those pumps are in effect included in different models and sizes in the catalogues, depending on the features and the required use.

[0033] The reduced power consumption of the pump, obtained through the use of an ejector pump as the fourth pumping section, is moreover favoured by the presence of the third pumping stage including a rotor disc with straight teeth. Indeed, at the exhaust pressure of 30 mbar it has been experienced that the pump with a toothed pumping stage has lower electric current absorption than a pump not equipped with a stage with toothed rotor disc.

Claims

1. A vacuum pump (5) comprising a plurality of pumping sections arranged between a suction duct (6) and an exhaust duct (16) and including at least one turbomolecular pumping section (1, 2, 3), charac-

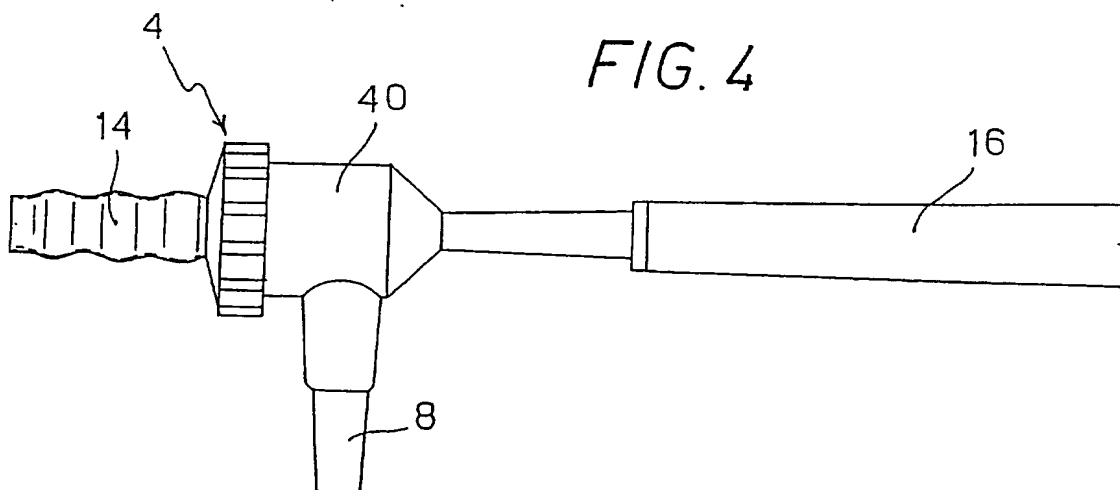
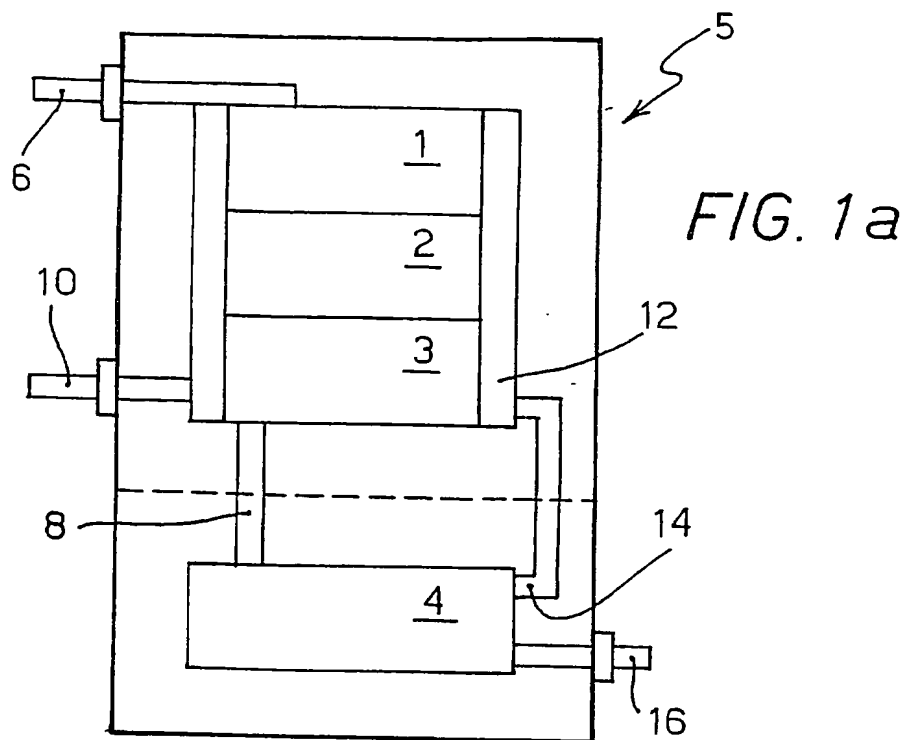
terised in that said pump comprises a pumping section (4) of the ejector or venturi pump type.

2. A vacuum pump (5) as claimed in claim 1, comprising a first pumping section (1) having pumping stages with bladed rotor discs (22a - 22h), a second pumping section (2) having pumping stages with smooth rotor discs (24a - 24f), a third pumping section (3) having at least one pumping stage with toothed rotor disc, and a fourth pumping section consisting of said pumping section (4) of the ejector or venturi pump type. 5 10
3. A vacuum pump (5) as claimed in claim 1 or 2, wherein said ejector pumping section (4) comprises a water-actuated venturi pump. 15
4. A vacuum pump (5) as claimed in claim 3 when appended to claim 2, wherein said venturi pump includes an inlet duct (14) for pressurised water, a suction duct (8) connected with a discharge port of said third pumping section (3), and a discharge duct connected with said exhaust duct (16). 20
5. A vacuum pump (5) as claimed in claim 3, wherein said venturi pump is fed with water from a cooling circuit (12) of said at least one turbomolecular pumping section. 25
6. A vacuum pump (5) as claimed in claim 2, wherein said pumping stage with toothed rotor disc comprises a rotor (26) with straight teeth (34). 30
7. A vacuum pump (5) as claimed in claim 6, wherein said rotor (26) with straight teeth is coupled with a stator ring (30) and wherein a tapered free channel (36) is defined between said rotor (26) and said stator ring (30). 35
8. A vacuum pump (5) as claimed in any preceding claim, wherein said pumping sections (1, 2, 3, 4) form a single body. 40

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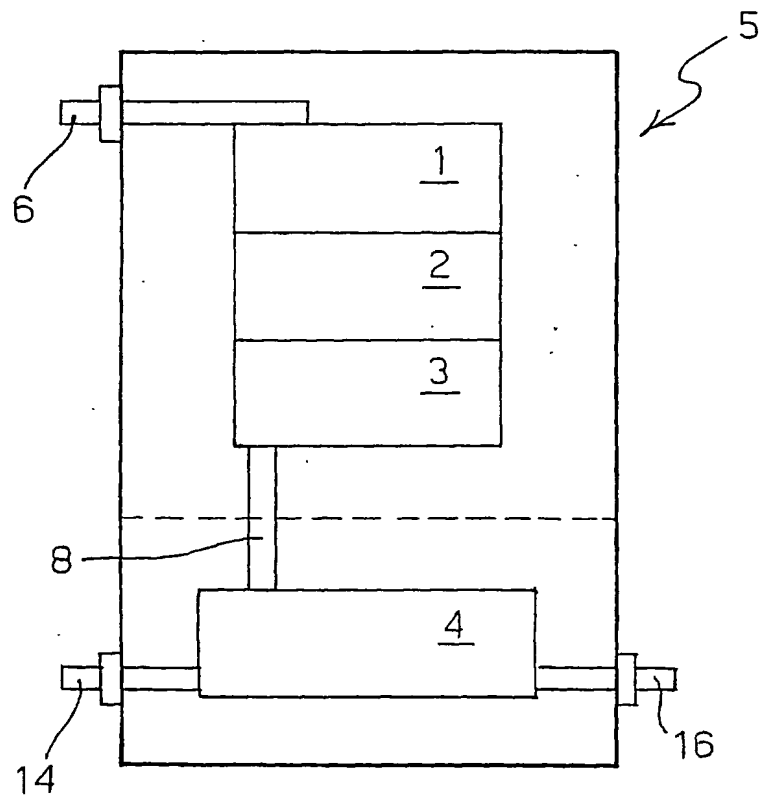


FIG. 1b

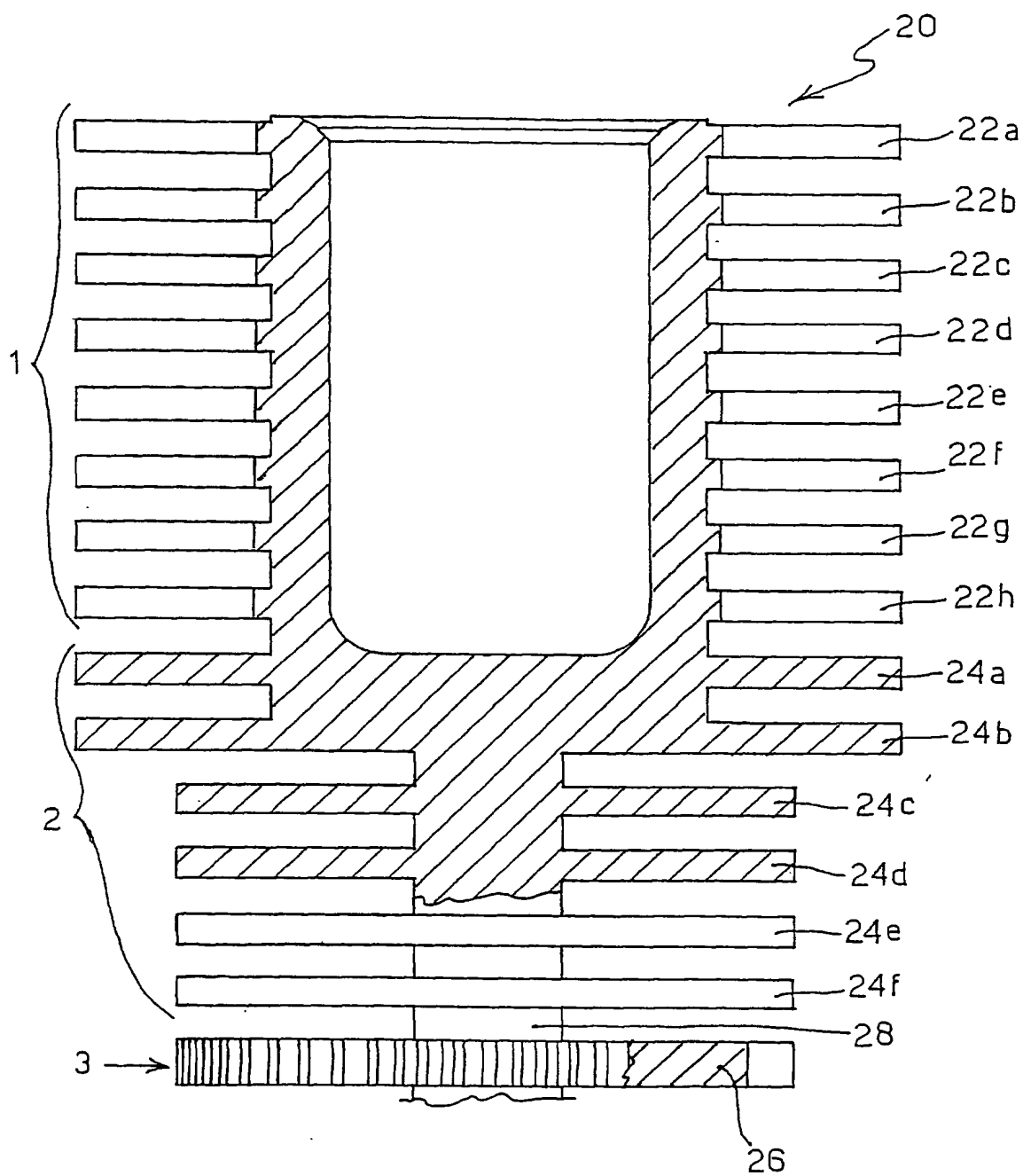


FIG. 2

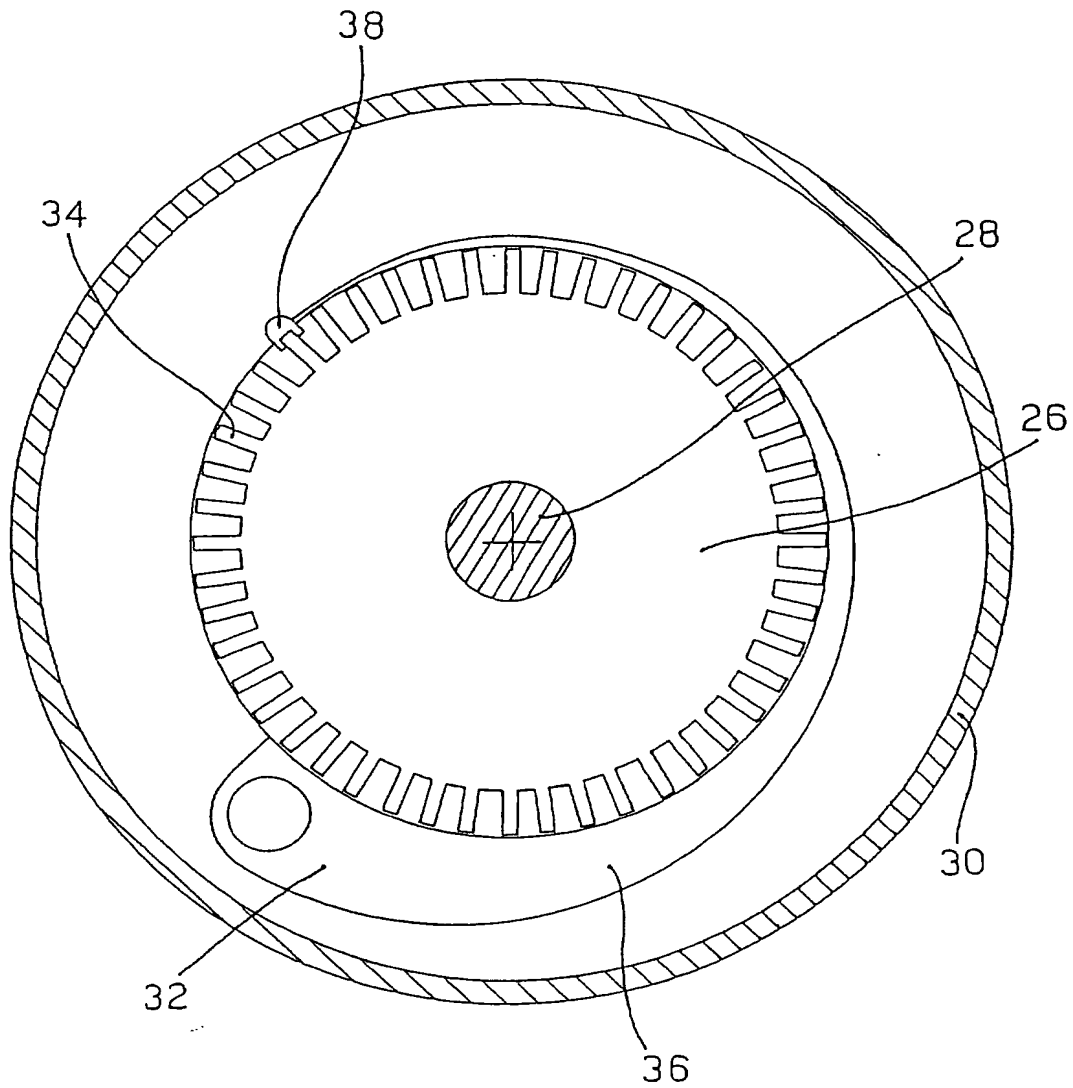


FIG. 3



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EUROPEAN SEARCH REPORT

Application Number
EP 01 83 0121

DOCUMENTS CONSIDERED TO BE RELEVANT			
Category	Citation of document with indication, where appropriate, of relevant passages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int.Cl.7)
A,D	EP 0 445 855 A (VARIAN SPA) 11 September 1991 (1991-09-11) * the whole document *	1,2,6,8	F04D19/04 F04D25/16 F04F5/20
A,D	US 4 797 068 A (HAYAKAWA TADASHI ET AL) 10 January 1989 (1989-01-10) * claim 1; figure 1 *	1	
A	US 5 118 251 A (SAULGEOT CLAUDE) 2 June 1992 (1992-06-02) * figure 1 *	1	
A	EP 0 340 685 A (NIPPON FERROFLUIDICS KK) 8 November 1989 (1989-11-08) * figure 1 *	1,8	
			TECHNICAL FIELDS SEARCHED (Int.Cl.7)
			F04D F04F
The present search report has been drawn up for all claims			
Place of search THE HAGUE		Date of completion of the search 5 July 2001	Examiner Teerling, J
CATEGORY OF CITED DOCUMENTS X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document T : theory or principle underlying the invention E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons & : member of the same patent family, corresponding document			

EPO FORM 1503 03 82 (P04C01)

**ANNEX TO THE EUROPEAN SEARCH REPORT
ON EUROPEAN PATENT APPLICATION NO.**

EP 01 83 0121

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05-07-2001

Patent document cited in search report	Publication date	Patent family member(s)	Publication date
EP 0445855 A	11-09-1991	IT 1241431 B	17-01-1994
		AT 113343 T	15-11-1994
		DE 69104749 D	01-12-1994
		ES 2064873 T	01-02-1995
		HK 1000016 A	03-10-1997
		JP 2115519 C	06-12-1996
		JP 4224295 A	13-08-1992
		JP 8026877 B	21-03-1996
		US 5238362 A	24-08-1993
US 4797068 A	10-01-1989	JP 7084871 B	13-09-1995
		JP 62291479 A	18-12-1987
		DE 3781482 A	08-10-1992
		DE 3781482 T	07-01-1993
		EP 0256234 A	24-02-1988
US 5118251 A	02-06-1992	FR 2656658 A	05-07-1991
		AT 105378 T	15-05-1994
		DE 69008683 D	09-06-1994
		DE 69008683 T	25-08-1994
		EP 0435291 A	03-07-1991
		ES 2053071 T	16-07-1994
		JP 4209980 A	31-07-1992
		SU 1776333 A	15-11-1992
EP 0340685 A	08-11-1989	JP 1277698 A	08-11-1989
		DE 68914320 D	11-05-1994
		DE 68914320 T	21-07-1994
		US 5092740 A	03-03-1992

EPO FORM P4459

For more details about this annex : see Official Journal of the European Patent Office, No. 12/82